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PATENT  
Attorney Docket No. 96790P453

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Junko Yotani et al.

Application No.: 10/824,310

Filed: April 13, 2004

For: **METHOD OF MANUFACTURING  
ELECTRON-EMITTING SOURCE**

Examiner: Stouffer, Kelly M.

Art Unit: 1762

Confirmation No.: 5984

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**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**

In response to the Final Office Action mailed February 15, 2007, in connection with the above referenced patent application, Applicants respectfully request entry of the following amendments and request reconsideration in view of the following remarks.